IN THE MITTED STATES PATENT AND TRADEMARK OFFICE

Zhanq Serial No.: 09/362,808 Art Unit Examiner:

Filed

: July 28, 1999

Tran,

Title

METHOD OF FABRICATING SEMICONDUCTOR DEVICE

#8/AMOT C 8/10/01 VShot

Commissioner or Patents Washington D.C.

AMENDMENT

Sir:

In response to the Official Action dated March 7, 2001, Paper No. 2, in the above-referenced application, please amend the above-identified application as follows.

In the Claims:

Please amend the claims as follows:

(Amended) A semiconductor device comprising:

a semiconductor layer having at least charmel, source and drain regions;

an insulating film formed on said semiconductor layer

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126.00 OP

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

August 6, 2001

Date of Deposit

Signature

Susan Regan

Typed or Printed Name of Person Signing Certificate